

Form PTO-1449 U.S. DEPARTMENT OF COMMERCE (REV.7-80) PATENT AND TRADEMARK OFFICE							Atty. Docket No.	Serial No.					
							GB 010071						
							Applicant Pieter J. Van der ZAAG et al.						
<b>INFORMATION DISCLOSURE CITATION</b> (Use several sheets if necessary)							Filing Date CONCURRENTLY	Group					
<b>U.S. PATENT DOCUMENTS</b>													
Ex. Int.		Document Number			Date	Name	Class	Sub-class	Filing Date If Approp.				
	AA	5	1	3	0	8	2	9	7/14/92	Shannon	359	59	
	AB												
	AC												
	AD												
	AE												
	AF												
<b>FOREIGN PATENT DOCUMENTS</b>													
		Document Number				Date	Country	Class	Sub-class	Trans.			
										Yes	No		
	AG												
	AH												
	AI												
	AJ												
	AK												
<b>OTHER (Including Author, Title, Date, Pertinent Pages, Etc.)</b>													
	AL	"Excimer-Laser-Produced Amorphous Silicon Vertical thin Film Transistors' by A. Saitoh et al, Jpn. J. Appl. Phys. Vol. 36 (1997) pp. 668-9											
	AM	"IBM Technical Disclosure Bulletin, Vol. 29 No. 5, Oct 1986, pp. 2224-6											
	AN												
Examiner							Date Considered						
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include a copy of this form with next communication to applicant.													

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<i>ff</i>	AL	"Excimer-Laser-Produced Amorphous Silicon Vertical thin Film Transistors' by A. Saitoh et al, Jpn. J. Appl. Phys. Vol. 36 (1997) pp. 668-9
<i>D</i>	AM	"IBM Technical Disclosure Bulletin, Vol. 29 No. 5, Oct 1986, pp. 2224-6
	AN	

Examiner *Og* Date Considered *1/08/03*

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<b>Notice of References Cited</b>	Application/Control No.	Applicant(s)/Patent Under Reexamination	
	10/142,587	VAN DER ZAAG ET AL.	
	Examiner	Art Unit	Page 1 of 1
David S Blum	2813		

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*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
A	US-US006461901B1	10-2002	Noguchi	438/158
B	US-US006414164B1	07-2002	Afzali-Ardakani et al	549/59
C	US-US006504175B1	01-2003	Mei et al	257/66
D	US-			
E	US-			
F	US-			
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N					
O					
P					
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**NON-PATENT DOCUMENTS**

*	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)		
U	Stanley Wolf SILICON PROCESSING for the VSLI ERA Vol. 1 Lattice Press 1986 pages 452,468-471,480,501-502		
V	John L. Vossen THIN FILM PROCESSES II Academic Press 1991 pages 34-35		
W			
X			

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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